



11 2 8 2003

## **TRANSMITTAL OF FORMAL DRAWINGS**

Docket No.

Dalton et al.

Serial No.

**Filing Date**

**Confirmation No.**

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**Examiner**

## Art Unit

## Invention: Fine-pitch device lithography using a sacrificial hardmask

**Address to:**

Address to:  
**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

Transmitted herewith are:

5 sheets of formal drawing(s) for this application.

☒ Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).

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AUG - 1 2003

RECEIVED



*Jay H. Lehr*

**Signature**

**Jay H. Anderson  
Registration No. 38,371  
Telephone No. 845-894-3667  
Fax No. 845-892-6363**

Dated: 23 July 03

I certify that this document and attached formal drawings are being deposited on 23 July 03 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

*Signature of Person Mailing Correspondence*

*Typed or Printed Name of Person Mailing Correspondence*